Asst. Prof. DOOYOUNG HAH

Personal Information

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International Researcher IDs

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Publons / Web Of Science ResearcherID: A-7587-2009

ScopusID: 6701711129

Yoksis Researcher ID: 216418

Education Information

Doctorate, Korea Advanced Institute Of Science And Technology, College Of Engineering, Department Of Electrical Engineering And Computer Science, South Korea 1996 - 2000

Postgraduate, Korea Advanced Institute Of Science And Technology, College Of Engineering, Department Of Electrical Engineering, South Korea 1994 - 1996

Undergraduate, Korea Advanced Institute Of Science And Technology, College Of Engineering, Department Of Electrical Engineering, South Korea 1990 - 1994

Foreign Languages

English, C1 Advanced Korean, C1 Advanced

Dissertations

Doctorate, A low voltage RF MEMS switch, Korea Advanced Institute Of Science And Technology, Engineering, Electrical Engineering, 2000

Postgraduate, Optical coupler sensor with movable waveguide, Korea Advanced Institute Of Science And Technology, Engineering, Electrical Engineering, 1995

Research Areas

Electrical and Electronics Engineering, Electronic, Sensing Devices and Transducers, Electronic Circuits, Microwave Circuits, Nanotechnology, Optics and Photonics, Passive Circuit Components, Cables, Switches and Connectors, Energy, Renewable energy, MEMS, Optical Materials and Devices, Semiconducting Materials and Devices, Engineering and Technology

Academic Titles / Tasks

Assistant Professor, Abdullah Gul University, Mühendislik Fakültesi, Elektrik-Elektronik Mühendisliği, 2018 - Continues

Assistant Professor, Abdullah Gul University, Mühendislik Fakültesi, Elektrik-Elektronik Mühendisliği, 2014 - 2018
Assistant Professor, Louisiana State University and Agricultural and Mechanical College, College Of Engineering, Electrical And Computer Engineering, 2005 - 2012

Research Assistant PhD, University of California, Los Angeles, School Of Engineering And Applied Science, Electrical Engineering, 2004 - 2005

Other, Electronics And Telecommunications Research Institute, Human İnformation Research, Microsystems, 2002 - 2004

Research Assistant PhD, University of California, Los Angeles, School Of Engineering And Applied Science, Electrical Engineering, 2000 - 2001

Research Assistant PhD, Korea Advanced Institute Of Science And Technology, Engineering, Electrical Engineering, 2000 - 2000

Research Assistant, Korea Advanced Institute Of Science And Technology, Engineering, Electrical Engineering, 1994 - 2000

Courses

AGUways II, Undergraduate, 2021 - 2022

ELECTRONICS I, Undergraduate, 2021 - 2022, 2020 - 2021, 2018 - 2019, 2017 - 2018, 2016 - 2017

Electronics II, Undergraduate, 2022 - 2023, 2021 - 2022, 2020 - 2021, 2016 - 2017

NANO-AND MICRO-SCALE SYSTEM DESIGN CAPSULE, Undergraduate, 2022 - 2023

Life at AGU, Undergraduate, 2022 - 2023

Sensor System Design Capsule, Undergraduate, 2022 - 2023, 2021 - 2022, 2020 - 2021

ELECTRONICS I LAB., Undergraduate, 2021 - 2022, 2020 - 2021, 2018 - 2019, 2017 - 2018, 2016 - 2017

ELECTRIC CIRCUITS I, Undergraduate, 2021 - 2022, 2020 - 2021

Electronics II Laboratory, Undergraduate, 2021 - 2022, 2020 - 2021, 2016 - 2017

ELECTRIC CIRCUITS I LABORATORY, Undergraduate, 2021 - 2022, 2020 - 2021

Digital Design Laboratory, Undergraduate, 2020 - 2021, 2019 - 2020, 2018 - 2019, 2017 - 2018, 2016 - 2017, 2015 - 2016

 $Digital\ Design,\ Undergraduate,\ 2020-2021,\ 2019-2020,\ 2018-2019,\ 2017-2018,\ 2016-2017,\ 2015-2016,\ 2018-2019,\ 2018-2$

Semiconductor Process and Device Fabrication, Undergraduate, 2020 - 2021, 2018 - 2019, 2017 - 2018

AGUways, Undergraduate, 2019 - 2020, 2018 - 2019, 2017 - 2018

Advising Theses

Içöz K., Hah D., Respiration monitoring using a flexible paper-based capacitive sensor, Postgraduate, İ.SOLAK(Student), 2022

HAH D., Foldable substrates for micro-ultrasonic transducers, Postgraduate, K.Balasubramanian (Student), 2011

HAH D., Surface-enhanced Raman spectroscopy substrates based on nanoporous silicon and pattern transfer, Postgraduate, P.Rao(Student), 2011

HAH D., Back-end processing of scanning mirrors with scratch drive actuators, Postgraduate, P.Pai(Student), 2011

HAH D., Two-dimensional microscanners with T-shaped hinges and piezoelectric actuators, Postgraduate,

W.Song(Student), 2009

HAH D., A study on buckled-beam actuators for RF MEMS applications, Postgraduate, S.Park(Student), 2007

Published journal articles indexed by SCI, SSCI, and AHCI

I. Electret vibration energy harvesters with symmetrically configured curved-beam hinges HAH D.

Microsystem Technologies, vol.30, no.3, pp.331-341, 2024 (SCI-Expanded)

II. Hemispherical-shell-shaped organic photovoltaic cells for absorption enhancement and improved angular coverage

HAH D.

Journal of Photonics for Energy, vol.14, no.1, 2024 (SCI-Expanded)

III. Analysis of electret-based vibration energy harvesting devices with curved-beam hinges HAH D.

Journal of Intelligent Material Systems and Structures, vol.34, no.14, pp.1702-1712, 2023 (SCI-Expanded)

IV. Respiration monitoring using a paper-based wearable humidity sensor, a step forward to clinical tests

Solak İ., Gençer S., Yıldırım B., Öznur E., HAH D., İÇÖZ K.

Sensors and Actuators A: Physical, vol.355, 2023 (SCI-Expanded)

V. RF MEMS variable attenuators with improved dB-linearity

HAH D.

Microsystem Technologies, vol.29, no.3, pp.311-320, 2023 (SCI-Expanded)

VI. Shell-shaped active layers for omnidirectional organic photovoltaic cells

HAH D.

Journal of Photonics for Energy, vol.12, no.4, 2022 (SCI-Expanded)

VII. AIN Piezoelectric Quad-Actuators for 2D Optical Micro Scanning

HAH D

INTEGRATED FERROELECTRICS, vol.225, no.1, pp.376-383, 2022 (SCI-Expanded)

VIII. Analysis of optical gyroscopes with vertically stacked ring resonators

HAH D

TURKISH JOURNAL OF ELECTRICAL ENGINEERING AND COMPUTER SCIENCES, vol.29, no.3, pp.1554-1564, 2021 (SCI-Expanded)

IX. Absorption enhancement by semi-cylindrical-shell-shaped structures for an organic solar cell application

HAH D.

APPLIED OPTICS, vol.59, no.28, pp.8645-8652, 2020 (SCI-Expanded)

X. Linear variable optical attenuators with shaped-finger comb-drive actuators

HAH D.

APPLIED OPTICS, vol.59, no.2, pp.277-284, 2020 (SCI-Expanded)

XI. Analytical design of MEMS variable capacitors based on shaped-finger comb-drives

Hah D.

Microsystem Technologies, 2019 (SCI-Expanded)

XII. All-polymer ultrasonic transducer design for an intravascular ultrasonography application HAH D.

TURKISH JOURNAL OF ELECTRICAL ENGINEERING AND COMPUTER SCIENCES, vol.27, no.4, pp.2444-2455, 2019 (SCI-Expanded)

XIII. C-band optical filters with micromechanical tuning

Hah D

MICROSYSTEM TECHNOLOGIES-MICRO-AND NANOSYSTEMS-INFORMATION STORAGE AND PROCESSING SYSTEMS, vol.24, pp.551-560, 2018 (SCI-Expanded)

XIV. A design method of comb-drive actuators for linear tuning characteristics in mechanically tunable optical filters

Hah D.

Microsystem Technologies, vol.23, pp.3835-3842, 2017 (SCI-Expanded)

XV. Clinical probe utilizing surface enhanced Raman scattering

Kim J., HAH D., Daniels-Race T., Feldman M.

JOURNAL OF VACUUM SCIENCE & TECHNOLOGY B, vol.32, no.6, 2014 (SCI-Expanded)

XVI. Note: Folded optical system for narrow forward looking probe

Hou H., Hah D., Kim J., Feldman M.

REVIEW OF SCIENTIFIC INSTRUMENTS, vol.85, no.2, 2014 (SCI-Expanded)

XVII. Nanorough gold for enhanced Raman scattering

Kim J., Kang K., Sarkar A., Malempati P., Hah D., Daniels-Race T., Feldman M.

JOURNAL OF VACUUM SCIENCE & TECHNOLOGY B, vol.31, no.6, 2013 (SCI-Expanded)

XVIII. Electrophoretic Deposition of Carbon Nanotubes on Silicon Substrates

Sarkar A., Hah D.

JOURNAL OF ELECTRONIC MATERIALS, vol.41, no.11, pp.3130-3138, 2012 (SCI-Expanded)

XIX. Combined soil moisture meter and penetrometer

Feldman M., Hah D., Hanifa K., Zhang Z.

Geotechnical Testing Journal, vol.35, no.3, pp.437-440, 2012 (SCI-Expanded)

XX. Mechanically tunable optical filters with a microring resonator

Hah D., Bordelon J., Zhang D.

APPLIED OPTICS, vol.50, no.22, pp.4320-4327, 2011 (SCI-Expanded)

XXI. Analysis of resonant optical gyroscopes with two input/output waveguides

Hah D., Zhang D.

OPTICS EXPRESS, vol.18, no.17, pp.18200-18205, 2010 (SCI-Expanded)

XXII. Experimental characterization of two-axis MEMS scanners with hidden radial vertical combdrive actuators and cross-bar spring structures

Tsai J., Hsieh T., Liao C., Chiou S., Hah D., Wu M. C.

JOURNAL OF MICROMECHANICS AND MICROENGINEERING, vol.19, no.4, 2009 (SCI-Expanded)

XXIII. Pre-shaped buckled-beam actuators: Theory and experiments

Park S., Hah D

SENSORS AND ACTUATORS A-PHYSICAL, vol.148, no.1, pp.186-192, 2008 (SCI-Expanded)

XXIV. Two-axis MEMS scanners with radial vertical combdrive actuators - design, theoretical analysis, and

Tsai J., Chiou S., Hsieh T., Sun C., Hah D., Wu M. C.

JOURNAL OF OPTICS A-PURE AND APPLIED OPTICS, vol.10, no.4, 2008 (SCI-Expanded)

XXV. 1 x N-2 wavelength-selective switch with two cross-scanning one-axis analog micromirror arrays in a 4-f optical system

Tsai J., Huang S., Hah D., Wu M.

JOURNAL OF LIGHTWAVE TECHNOLOGY, vol.24, no.2, pp.897-903, 2006 (SCI-Expanded)

XXVI. MEMS-actuated photonic crystal switches

Lee M., Hah D., Lau E., Toshiyoshi H., Wu M.

IEEE PHOTONICS TECHNOLOGY LETTERS, vol.18, pp.358-360, 2006 (SCI-Expanded)

XXVII. Surface- and bulk-micromachined two-dimensional scanner driven by angular vertical comb actuators

Piyawattanametha W., Patterson P., Hah D., Toshiyoshi H., Wu M.

JOURNAL OF MICROELECTROMECHANICAL SYSTEMS, vol.14, no.6, pp.1329-1338, 2005 (SCI-Expanded)

XXVIII. A self-aligned vertical comb-drive actuator on an SOI wafer for a 2D scanning micromirror Hah D., Choi C., Kim C., Jun C.

JOURNAL OF MICROMECHANICS AND MICROENGINEERING, vol.14, no.8, pp.1148-1156, 2004 (SCI-Expanded)

XXIX. Angular vertical comb-driven tunable capacitor with high-tuning capabilities

Nguyen H., Hah D., Patterson P., Chao R., Piyawattanametha W., Lau E., Wu M.

JOURNAL OF MICROELECTROMECHANICAL SYSTEMS, vol.13, no.3, pp.406-413, 2004 (SCI-Expanded)

XXX. Theory and experiments of angular vertical comb-drive actuators for scanning micromirrors Hah D., Patterson P., Nguyen H., Toshiyoshi H., Wu M.

IEEE JOURNAL OF SELECTED TOPICS IN QUANTUM ELECTRONICS, vol.10, no.3, pp.505-513, 2004 (SCI-Expanded)

XXXI. Open-loop operation of MEMS-based 1 X N wavelength-selective switch with long-term stability and repeatability

Tsai J., Huang S., Hah D., Toshiyoshi H., Wu M.

IEEE PHOTONICS TECHNOLOGY LETTERS, vol.16, no.4, pp.1041-1043, 2004 (SCI-Expanded)

XXXII. Low-voltage, large-scan angle MEMS analog micromirror arrays with hidden vertical comb-drive actuators

Hah D., Huang S., Tsai J., Toshiyoshi H., Wu M.

JOURNAL OF MICROELECTROMECHANICAL SYSTEMS, vol.13, no.2, pp.279-289, 2004 (SCI-Expanded)

XXXIII. A low voltage actuated microelectromechanical switch for RF application

Hah D., Yoon E., Hong S.

JAPANESE JOURNAL OF APPLIED PHYSICS PART 1-REGULAR PAPERS SHORT NOTES & REVIEW PAPERS, vol.40, pp.2721-2724, 2001 (SCI-Expanded)

XXXIV. A low-voltage actuated micromachined microwave switch using torsion springs and leverage Hah D., Yoon E., Hong S.

IEEE TRANSACTIONS ON MICROWAVE THEORY AND TECHNIQUES, vol.48, no.12, pp.2540-2545, 2000 (SCI-Expanded)

XXXV. An optomechanical pressure sensor using multimode interference couplers with polymer waveguides on a thin p(+)-Si membrane

Hah D., Yoon E., Hong S.

SENSORS AND ACTUATORS A-PHYSICAL, vol.79, no.3, pp.204-210, 2000 (SCI-Expanded)

XXXVI. An optomechanical pressure sensor using multimode interference couplers

Hah D., Yoon E., Hong S.

JAPANESE JOURNAL OF APPLIED PHYSICS PART 1-REGULAR PAPERS SHORT NOTES & REVIEW PAPERS, vol.38, pp.2664-2668, 1999 (SCI-Expanded)

Articles Published in Other Journals

I. Flexible and Ecofriendly Keypad Based on Paper and Pencil

Er S. F., Kalabey N., HAH D.

IEEE Sensors Letters, vol.7, no.11, 2023 (ESCI)

Refereed Congress / Symposium Publications in Proceedings

I. Effects of Curved-Beam Heights to Harvested Energy in a Blanaced Comb-Drive Configuration HAH D.

Symposium on Design, Test, Integration and Packaging of MEMS and MOEMS, Paris, France, 25 - 27 August 2021

II. Quasi-Static Operation of 2-Axis-Tilt Microscanners with AlN Piezoelectric Quad-Actuators HAH D.

Symposium on Design, Test, Integration and Packaging of MEMS and MOEMS, Paris, France, 25 - 27 August 2021

III. Planar MEMS Variable Optical Attenuators (VOAs) with Linear Attenuation-Voltage Characteristics HAH D.

2019 Symposium on Design, Test, Integration and Packaging of MEMS and MOEMS, DTIP 2019, Paris, France, 12 - 15 May 2019

IV. Analytical design of linear variable capacitors with shaped-finger comb-drive actuators

20th Symposium on Design, Test, Integration and Packaging of MEMS and MOEMS, DTIP 2018, Roma, Italy, 22 - 25 May 2018, pp.1-5

V. Design of capacitive micromachined ultrasonic transducers (CMUTs) on a flexible substrate for intravascular ultrasonography (IVUS) applications

HAH D., Je C. H., Lee S.

19th Symposium on Design, Test, Integration and Packaging of MEMS/MOEMS, DTIP 2017, Bordeaux, France, 29 May - 01 June 2017

VI. An FEM study of die attach packaging effect on nanomechanical Si optical filters

Seok S., HAH D.

19th Symposium on Design, Test, Integration and Packaging of MEMS/MOEMS, DTIP 2017, Bordeaux, France, 29 May - 01 June 2017

VII. Design of wide-band tunable optical filters with cascaded microring resonators and shaped-finger comb-drive actuators

HAH D.

18th Symposium on Design, Test, Integration and Packaging of MEMS/MOEMS, DTIP 2016, Budapest, Hungary, 30 May - 02 June 2016

VIII. Design of mechanically tunable optical filters with microring resonators

HAH D., Bordelon J.

17th Symposium on Design, Test, Integration and Packaging of MEMS/MOEMS, DTIP 2015, Montpellier, France, 27 - 30 April 2015

IX. Performance Improvement of a Two-Axis Radial-Vertical-Combdrive Scanner by Using a Symmetric Spring Design

Hsieh T., Chang Y., Chiou S., Tsai J., Hah D., Wu M. C.

IEEE/LEOS International Conference on Optical MEMS and Nanophotonics, Freiburg, Germany, 11 - 14 August 2008, pp.108-109

X. A two-axis MEMS scanner driven by radial vertical combdrive actuators

Chiou S., Hsieh T., Tsai J., Sun C., Hah D., Wu M. C.

IEEE/LEOS International Conference on Optical MEMS and Nanophotonics, Hualian, Taiwan, 12 - 16 August 2007, pp.83-84

XI. Silicon-based on-chip micromirrors for DWDM wavelength-selective crossconnects

Chi C., Hou C., Lee C., HAH D., Wu M. C.

IEEE/LEOS International Conference on Optical MEMS and Their Applications Conference, 2006, Big Sky, MT, United States Of America, 21 - 24 August 2006, pp.130-131

XII. Integrated 1x4 wavelength-selective switch with on-chip MEMS micromirrors

Chi C., Tsai J., Lee M. M., HAH D., Wu M. C.

Conference on Lasers and Electro-Optics, CLEO 2006, Long Beach, CA, United States Of America, 21 May 2006

XIII. Silicon-based monolithic 4x4 wavelength-selective cross connect with on-chip micromirrors

Chi C., Tsai J., Hah D., Mathai S., Lee M. M., Wu M. C.

Conference on Optical Fiber Communications/National Fiber Optic Engineers Conference, California, United States Of America, 5 - 10 March 2006, pp.91-92

XIV. Solid-immersion micromirror with enhanced angular deflection for silicon-based planar lightwave

Chi C., Tsai J., Hah D., Jeong K., Wu M.

10th IEEE/LEOS International Conference on Optical MEMs and Their Applications, Oulu, Finland, 1 - 04 August 2005, pp.131-132

XV. A large port-count 1x32 wavelength-selective switch using a large scan-angle, high fill-factor, two-axis analog micromirror array

Tsai J., Fan L., Chi C., HAH D., Wu M. C.

30th European Conference on Optical Communication, Stockholm, Sweden, 5 - 09 September 2004, pp.1-2

XVI. A high fill-factor, large scan-angle, two-axis analog micromirror array driven by leverage mechanism Tsai J., Fan L., HAH D., Wu M. C.

International Conference on Optical MEMS and Their Applications, Takamatsu, Japan, 22 - 26 August 2004, pp.30-31

XVII. Scanning micromirrors: An overview

Patterson P., Hah D., Fujino M., Piyawattanametha W., Wu M.

Conference on Optomechatronic Micro/Nano Components, Devices and Systems, Pennsylvania, United States Of America, 27 - 28 October 2004, vol.5604, pp.195-207

XVIII. A Surface and Bulk Micromachined Angular Vertical Combdrive for Scanning Micromirrors

Piyawattanametha W., Patterson P., Wu M., HAH D., Toshiyoshi H.

Optical Fiber Communication Conference (OFC), Atlanta, United States Of America, vol.86, pp.251-252

XIX. Wavelength-selective 1xN2 switches with two-dimensional input/output fiber arrays

Tsai J., Huang S., HAH D., Wu M. C.

CLEO 2003, Baltimore, United States Of America, 1 - 06 June 2003, pp.772-774

XX. MOEM scanners for optical networks

HAH D., Choi C., Jun C., Kim Y., Patterson P., Toshiyoshi H., Wu M. C.

The 9th KIEE MEMS symposium, Seoul, South Korea, 06 February 2003, pp.13-19

XXI. Nano-electro-mechanical photonic crystal switches

Lee M., HAH D., Lau E., Toshiyoshi H., Wu M. C.

6th International Symposium on Contemporary Photonics Technology (CPT 2003), Tokyo, Japan, 15 - 17 January 2003, pp.135-138

$XXII. \quad 1xN(2) \ wavelength-selective \ switch \ with \ telescope-magnified \ 2D \ input/output \ fiber \ collimator \ array$

Tsai J., Huang S., Hah D., Wu M.

IEEE/LEOS International Conference on Optical MEMS, Hawaii, United States Of America, 18 - 21 August 2003, pp.45-46

XXIII. A self-aligned vertical comb-drive actuator using surface micromachining for scanning micromirrors

Hah D., Choi C., Jun C., Kim Y.

IEEE/LEOS International Conference on Optical MEMS, Hawaii, United States Of America, 18 - 21 August 2003, pp.151-152

XXIV. A 2D scanner by surface and bulk micromachined angular vertical comb actuators

Piyawattanametha W., Patterson P., Hah D., Toshiyoshi H., Wu M.

IEEE/LEOS International Conference on Optical MEMS, Hawaii, United States Of America, 18 - 21 August 2003, pp.93-94

XXV. Wavelength-selective 1×N2 switches with two-dimensional input/output fiber arrays

Tsai J., Huang S., HAH D., Wu M. C.

Conference on Lasers and Electro-Optics (CLEO); Postconference Digest, Baltimore, MD, United States Of America, 1 - 06 June 2003, vol.88, pp.775-777

XXVI. Analog micromirror arrays with orthogonal scanning directions for wavelength-selective 1XN(2) switches

Tsai J., Huang S., Hah D., Wu M.

12th International Conference on Solid-State Sensors, Actuators and Microsystems (TRANSDUCERS 03),

Massachusetts, United States Of America, 8 - 12 June 2003, pp.1776-1779

XXVII. MEMS photonic devices and their applications

Wu M., HAH D., Huang S., Tsai J.

7th Optoelectronics and communications conference (OECC 2002), Yokohama, Japan, 8 - 12 July 2002, pp.38-39

XXVIII. A novel tunable MEMS capacitor based on angled vertical comb drive actuators

Nguyen H., HAH D., Patterson P., Chao R., Piyawattanametha W., Wu M. C.

Hilton Head 2002 Solid-State Sensor & Actuator Workshop, Hilton Head Island, United States Of America, 3 - 06 June 2002, pp.277-280

XXIX. Low voltage MEMS micromirror arrays with hidden vertical comb-drive actuators

HAH D., Huang S., Nguyen H., Chang H., Tsai J., Toshiyoshi H., Wu M. C.

Hilton Head 2002 Solid-State Sensor & Actuator Workshop, Hilton Head Island, United States Of America, 3 - 06 June 2002, pp.11-14

XXX. Design of electrostatic actuators for MOEMS applications

Hah D., Toshiyoshi H., Wu M.

Conference on Design, Test, Integration, and Packaging of MEMS/MOEMS 2002, Cannes, France, 6 - 08 May 2002, vol.4755, pp.200-207

XXXI. Open-loop operation of MEMS WDM routers with analog micromirror array

Huang S., Tsai J., Hah D., Toshiyoshi H., Wu M.

IEEE/LEOS International Conference on Optical MEMS, LUGANO, Switzerland, 20 - 23 August 2002, pp.179-180

XXXII. Microelectromechanical scanning devices for optical networking applications

Wu M. C., HAH D., Patterson P. R., Toshiyoshi H.

2002 IEEE International Solid-State Circuits Conference, San Francisco, CA, United States Of America, 3 - 07 February 2002, pp.288

XXXIII. Advanced MEMS for photonics

Wu M., Patterson P., HAH D., Lee M., Huang S., Tsai J.

60th Device Research Conference, DRC 2002, California, United States Of America, 24 - 26 June 2002, vol.2002-January, pp.13-16

XXXIV. Recent advances in optical MEMS devices and systems

Patterson P., Hah D., Lee M., Tsai J., Wu M.

Conference on Photonic Devices and Algorithms for Computing IV, Washington, United States Of America, 8 - 09 July 2002, vol.4788, pp.1-8

XXXV. MOEMS electrostatic scanning micromirrors design and fabrication

Patterson P., Hah D., Su G., Toshiyoshi H., Wu M.

1st International Symposium on Integrated Electronics, Pennsylvania, United States Of America, 12 - 17 May 2002, vol.2002, pp.369-380

XXXVI. A Low Voltage, Large Scan Angle MEMS Micromirror Array with Hidden Vertical Comb-Drive Actuators for WDM Routers

HAH D., Huang S., Nguyen H., Chang H., Wu M. C., Toshiyoshi H.

Optical Fiber Communication Conference, OFC 2002, California, United States Of America, 17 March 2002, pp.92-93

XXXVII. MEMS WDM routers using analog micromirror arrays

Wu M., Tsai J., Huang S., Hah D.

15th Annual Meeting of the IEEE-Lasers-and-Electro-Optics-Society, Glasgow, England, 10 - 14 November 2002, pp.582-583

XXXVIII. A scanning micromirror with angular comb drive actuation

Patterson P., Hah D., Nguyen H., Toshiyoshi H., Chao R., Wu M.

15th IEEE International Conference on Micro Electro Mechanical Systems (MEMS 2002), Nevada, United States Of America, 20 - 24 January 2002, pp.544-547

XXXIX. Integration of a honeycomb micromirror with a surface micromachined 2D scanner for improved performance

Patterson P., Su G., HAH D., Wu M. C.

AVS 48th International Symposium, San Francisco, United States Of America, 29 October - 02 November 2001, pp.1

XL. An angular vertical comb drive actuator for scanning micromirrors

Patterson P., HAH D., Chang H., Toshiyoshi H., Wu M. C.

International Conference on Optical MEMS and Their Applications, Okinawa, Japan, 25 - 28 September 2001, pp.25-26

XLI. Low voltage actuated RF MEMS switches using push-pull operation

HAH D., Yoon E., Hong S.

International Conference on Solid State Devices and Materials, Sendai, Japan, 28 - 31 August 2000, pp.392-393

XLII. Surface micromachined microwave switch with push-pull configuration

HAH D., Yoon E., Hong S.

The 2nd Korean MEMS Conference, Daejeon, South Korea, 07 April 2000, pp.263-268

XLIII. A low voltage actuated micromachined microwave switch using torsion springs and leverage Hah D., Yoon E., Hong S.

IEEE MTT-S International Microwave Symposium (IMS2000), Massachusetts, United States Of America, 11 - 16 June 2000, pp.157-160

XLIV. Optomechanical pressure sensors using multi-mode interference couplers on thin p+-Si membranes HAH D., Yoon E., Hong S.

The 6th Korean Conference on Semiconductor, Seoul, South Korea, 01 February 1999, pp.175-176

XLV. Optical coupler sensor with movable waveguide

HAH D., Hong S., Kwon Y.

Supported Projects

HAH D., Project Supported by Higher Education Institutions, Theoretical study on optical filters with nanoelectromechanical tuning, 2016 - 2018

HAH D., Other International Funding Programs, Optical probe for microscopic cancer identification in minute structures, 2009 - 2013

HAH D., Other International Funding Programs, Carbon nanotube reinforced metal matrix composites for microelectromechanical systems (MEMS) applications, 2011 - 2012

HAH D., Other International Funding Programs, Compact MEMS-based optical probe modules for optical coherence tomography (OCT) application, 2006 - 2011

HAH D., Other International Funding Programs, Room temperature deposition of carbon nanotube film, 2010 - 2010

 $HAH\ D\text{,,}\ Other\ International\ Funding\ Programs,\ Micro\ glow\ discharge\ devices,\ 2009-2010$

HAH D., Other International Funding Programs, Enhancement of nanoscale surface characterization capabilities for multi-disciplinary researches, 2007 - 2010

HAH D., Other International Funding Programs, Combined soil moisture meter and dynamic cone penetrometer (DCP), 2007 - 2008

HAH D., Other International Funding Programs, Low-voltage, laterally-driven RF microelectromechanical (MEM) switches fabricated by single-mask process, 2006 - 2007

Metrics

Publication: 83

Citation (WoS): 945 Citation (Scopus): 1134 H-Index (WoS): 16 H-Index (Scopus): 17